

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

IN RE APPLICATION OF: Yoshitake NATSUME, et al.

SERIAL NO: 10/554,397

GAU: 1795

FILED: September 26, 2006

EXAMINER: HAN, KWANG S.

FOR: NEGATIVE ELECTRODE FOR LITHIUM SECONDARY CELL, LITHIUM SECONDARY CELL EMPLOYING THE NEGATIVE ELECTRODE, FILM DEPOSITION MATERIAL B USED FOR FORMING NEGATIVE ELECTRODE, AND PROCESS FOR PRODUCING NEGATIVE ELECTRODE

**REQUEST FOR EXTENSION OF TIME  
UNDER 37 C.F.R. 1.136**

COMMISSIONER FOR PATENTS  
ALEXANDRIA, VIRGINIA 22313

SIR:

It is hereby requested that a **one** month extension of time be granted to March 23, 2010 for

- filing a response to the Official Action dated: November 23, 2009
- responding to the requirements in the Notice of Allowability dated:
- filing the Formal Drawings. The Issue Fee due has been timely filed.
- responding to the Notice to File Missing Parts of Application dated:
- filing a Notice of Appeal. A timely response to the final rejection, due has been filed.
- filing an Appeal Brief. A Notice of Appeal was filed on:
- Applicant claims small entity status. See 37 CFR 1.27.

The required fee of \$130.00 is being made by credit card payment online (if electronically filed), or is attached hereto (if paper filed), and any further charges may be made against the Attorney of Record's Deposit Account No. 15-0030.

Respectfully Submitted,

OBLON, SPIVAK, McCLELLAND,  
MAIER & NEUSTADT, L.L.P.  
Norman F. Oblon



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